



Receipt #5
CFR.
SDavis
5/13/02

IN THE

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Tony P. Chiang et al.
TITLE: Method for Integrated In-Situ Cleaning and Subsequent Atomic Layer Deposition Within a Single Processing Chamber
SERIAL NO.: 09/994,279
FILING DATE: November 26, 2001
EXAMINER: Unknown
GROUP ART UNIT: 2812
ATTY.DKT.NO.: PA1688US

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

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REQUEST FOR CORRECTED FILING RECEIPT

SIR:

Applicants hereby request the United States Patent and Trademark Office correct its records and issue a corrected filing receipt showing the correct title of the invention. On the Filing Receipt, the word subsequent in the title is incorrectly spelled susequent. For reference purposes, Applicants enclose a copy of the incorrect filing receipt with the desired correction indicated in red ink. Applicants also enclose a copy of the Utility Patent Application Transmittal showing the correctly spelled title.

Since the paperwork submitted to the United States Patent and Trademark Office correctly indicated the spelling of the title, Applicants believe there is no fee for this request.

However, the Commissioner is hereby authorized to charge any additional fees which may be required to Deposit Account No. 06-0600. A copy of this letter is enclosed for this purpose.

Respectfully submitted,

Tony P. Chiang et al.

Dated: APRIL 8, 2002

By: 

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on the date printed below:

Dated: APRIL 8, 2002

By: 

Bradley W. Scheer, Reg. No. 47,059



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/994,279	11/26/2001	2812	388	PA1688US	7	22	3

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CONFIRMATION NO. 8825

FILING RECEIPT



OC000000007172156

Date Mailed: 12/07/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Karl F. Leeser, Sunnyvale, CA;

Domestic Priority data as claimed by applicant

THIS APPLN CLAIMS BENEFIT OF 60/254,280 12/06/2000
AND CLAIMS BENEFIT OF 60/255,812 12/15/2000

Foreign Applications

If Required, Foreign Filing License Granted 12/07/2001

Projected Publication Date: 06/06/2002

Non-Publication Request: No

Early Publication Request: No

** SMALL ENTITY **

Title

Method for integrated in-situ cleaning and ~~subsequent~~ ^{subsequent} atomic layer deposition within a single processing chamber

Preliminary Class

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15

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